## Application/Control No. Applicant(s)/Patent Under Reexamination 10/658,840 DAMMEL ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 John S. Chu 1752 **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY US-6,727,032 Α 04-2004 Suwa et al. 430/170 \* В US-6,136,499 10-2000 Goodall et al. 430/270.1 С US-D US-US-Ε US-F G US-Н US-US-1 J US-Κ US-US-L М US-**FOREIGN PATENT DOCUMENTS** Document Number Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R S T **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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